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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Kazuya FUJITA et al.

**U.S.S.N.:** 10/773,809

**GROUP ART UNIT:** 2816

**FILED:** Herewith

**EXAMINER:** Not Yet Known

**FOR:** SOLID STATE IMAGING DEVICE, SEMICONDUCTOR  
WAFER, OPTICAL DEVICE MODULE, METHOD OF SOLID  
STATE IMAGING DEVICE FABRICATION, AND METHOD  
OF OPTICAL DEVICE MODULE FABRICATION

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

**REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS**

Dear Sir:

Applicants hereby request that all further communications from the U.S. Patent and Trademark Office in connection with the above-referenced application be sent to the following address:

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**CERTIFICATE OF MAILING**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 26, 2004.

By: Lee Dunkle  
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Respectfully submitted,

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